

EAST Search History

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|---|---|------------------|---------|---------------------|
| L1 | 0 | ("oxidation and ((nozzle or inlet) near5 position) and (furnace or reactor or chamber) and (polysilicon or wafer)").PN. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2008/04/17 19:31 |
| L2 | 1046 | oxidation and ((nozzle or inlet) near5 position)and (furnace or reactor or chamber) and (polysilicon or wafer) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2008/04/17 19:33 |
| L3 | 624 | :2 and (uniform or uniformity) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2008/04/17 19:36 |

4/17/08 7:50:16 PM

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